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INFORMATION DISCUSSIBLE CITATION						BUR920040033U APPLICANT(S)	IS1	10/711,818				
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MAR 1 4 2005 (USA several sheets if necessary)						William J. Murphy et al.  FILING DATE GROUP ART UNIT						
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.												

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